

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Here PATENT application of:)

Shinpei YAMAZAKI et al.)

Serial No. 09/295,607)

Filed: 04/22/1999)

For: SEMICONDUCTOR DEVICE HAVING)

ALUMINUM NITRIDE FILM)

Art Unit: 2811

Examiner: S. Loke

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 2/23/2001.

INFORMATION DISCLOSURE STATEMENT ANDSUPPLEMENTAL TO INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

BEST AVAILABLE COPY

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The enclosed references Japanese Patent Laid Open Nos. 01-156725 and 53-027483 were submitted with abstract translations on December 29, 1999. Full translation are being submitted herewith.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,

Jeffrey L. Costellia
Reg. No. 35,483

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110

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